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CONFIRMATION NO. 4531

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
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RULE						
APPLICANTS Fumitsugu Fukuyo, Hamamatsu-shi, JAPAN; Kenshi Fukumitsu, Hamamatsu-shi, JAPAN; Naoki Uchiyama, Hamamatsu-shi, JAPAN; Ryuji Sugiura, Hamamatsu-shi, JAPAN;						
** CONTINUING DATA ***** This application is a 371 of PCT/JP03/11624 09/11/2003						
** FOREIGN APPLICATIONS ***** JAPAN 2002-351600 12/03/2002						
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **						
Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No		JAPAN	24	28	8
Verified and Acknowledged	/ELIAS ULLAH/ Examiner's Signature		Initials			
ADDRESS DRINKER BIDDLE & REATH ATTN: INTELLECTUAL PROPERTY GROUP ONE LOGAN SQUARE 18TH AND CHERRY STREETS PHILADELPHIA, PA 19103-6996 UNITED STATES						
TITLE Method for cutting semiconductor substrate						
FILING FEE RECEIVED 4830	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees		
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